

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 10/208,154
Priority Filing Date July 29, 2002
Inventor..... Jerome M. Eldridge
Assignee..... Micron Technology, Inc.
Priority Group Art Unit 2822
Priority Examiner K. Duong
Attorney's Docket No. MI22-2395
Title: Perovskite-Type Material Forming Methods, Capacitor Dielectric Forming Methods,
and Capacitor Constructions

PRELIMINARY AMENDMENT

To: Box PATENT APPLICATION
Attn: Art Unit 2822
Commissioner for Patents and Trademarks
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AMENDMENTS

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